DE LA RECHERCHE À L'INDUSTRIE





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## CRITICAL DESIGN REVIEW #1 FOR MEDIUM BETA CAVITY CRYOMODULES

3-4 APRIL 2017

**COUPLERS** 

**CHRISTIAN ARCAMBAL** 





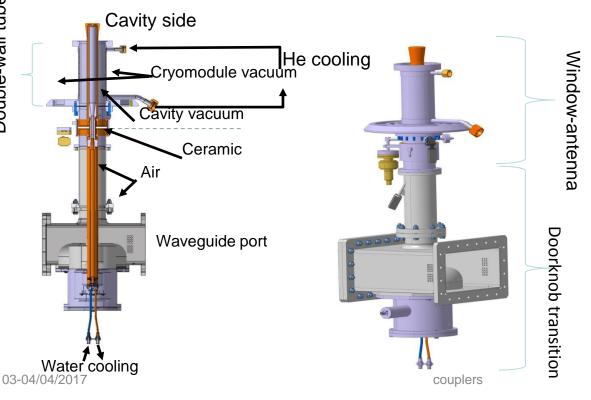
- Overview of the couplers
  - Window-antenna
  - Double-wall tube
  - Doorknob transition
  - Conditioning box
- Controls and checks during manufacturing of the prototypes
- RF characterization of each part
- Conditioning of the 2 first pairs of couplers



### **OVERVIEW OF THE COUPLER**



- Three main parts: window-antenna, double wall tube, doorknob transition
- Window-antenna and doorknob transitions common to medium and high beta cavities
- Double-wall tube slightly different between the 2 kinds of cavities: only the tube length is modified



RF frequency	704.42MHz
Repetition frequency	14 Hz
Incident RF power	1.2 MW
RF pulse width in full reflection	500 μs
(all phases)	
RF pulse width in travelling	3.6 ms
waves	
Voltage withstand (voltage	±10 kV
between internal conductor	
and external conductor)	

#### **Technical specifications**

Nominal temperature	20°C
Temperature during baking	Max : 200°C for 100h
Water pressure in cooling	3 bars
circuit	
Water flow in cooling circuit	3 l/min
Water temperature in the	from 20 to 25°C
antenna	

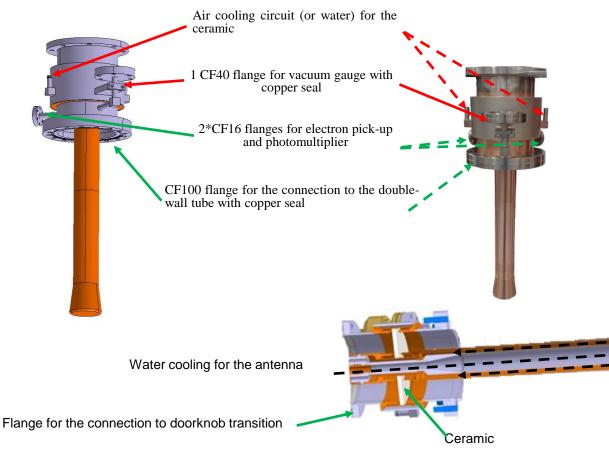
**Use conditions** 



#### WINDOW ANTENNA



- Vacuum tightness obtained with the brazing of ceramic
- Design of chokes to improve the impedance matching
- TiN coating for multipactor effect (vacuum side)



Electron pick-up



Technical note "Estimation de la longueur du pick-up électron »

#### Vacuum gauge (IKR070 from Pfeiffer)



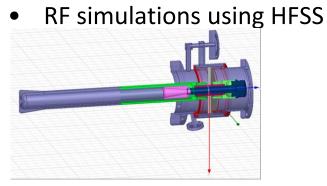
#### Window for photomultiplier

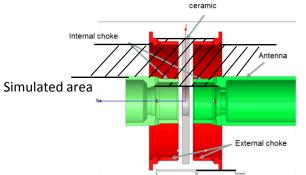




## PEAK FIELD AROUND THE CERAMIC WINDOW **AND RF MATCHING**

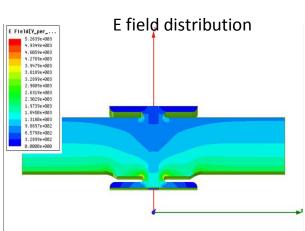


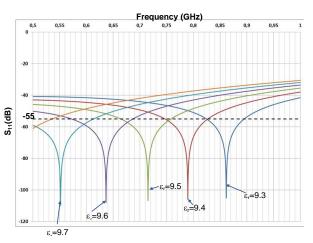




	ceramic	Liectric field fildx
		internal choke (fu
Internal choke		Dielectric losses
		wave)
		Dielectric los
Simulated area		reflection)
X*		RF losses for ex
		(travelling wave)
		RF losses for ex
	External choke	(full reflection)
	and the second s	RF losses for int
	0 25 70 (mm)	(travelling wave)
		RF losses for int
		(full reflection)
Port 1 Air/var Simulation model	cuum cuum	Port 2
03-04/04/2017 Ir	nternal choke	

Parameters	Nominal window
Matching frequency (ε <sub>r</sub> nominal)	710.2 MHz
Bandwidth at -55dB	94 MHz (753-659)
Frequency shift for a	+ 75 MHz (Δε <sub>r</sub> =-
permittivity shift =0.1	0.1)
	-78 MHz
	(Δε <sub>r</sub> =+0.1)
Electric field max on surface of	1.56 MV/m
internal choke (full	
transmission)	
Electric field max on surface of	3.12 MV/m
internal choke (full reflection)	
Dielectric losses (travelling wave)	10 W
Dielectric losses (full reflection)	29.4 W
RF losses for external choke (travelling wave)	1.2 W
RF losses for external choke (full reflection)	1.4 W
RF losses for internal choke (travelling wave)	6.1 W
RF losses for internal choke (full reflection)	6.8 W



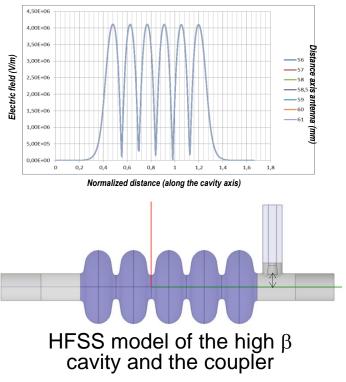


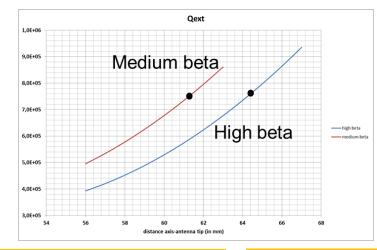
Technical note "Etude de la sensibilité des cotes de la fenêtre du coupleurs (pour linac à protons) sur les performances RF"





- Procedure to evaluate the antenna length
  - HFSS simulation to determine the distance cavity axis –antenna tip + curve interpolation : dist=61.26mm for the medium β cavity, dist= 64.41mm for the high β cavity
  - Taking into account the seals (compression) and thermal expansion of the double wall tube (stainless steel 316L)
     HFSS model of the





Technical note "Calculation of the coupler antenna length (medium beta cavity)»

Technical note "Estimation de la longueur du pick-up électron (medium beta cavity) for drawing»

medium  $\beta$  cavity and

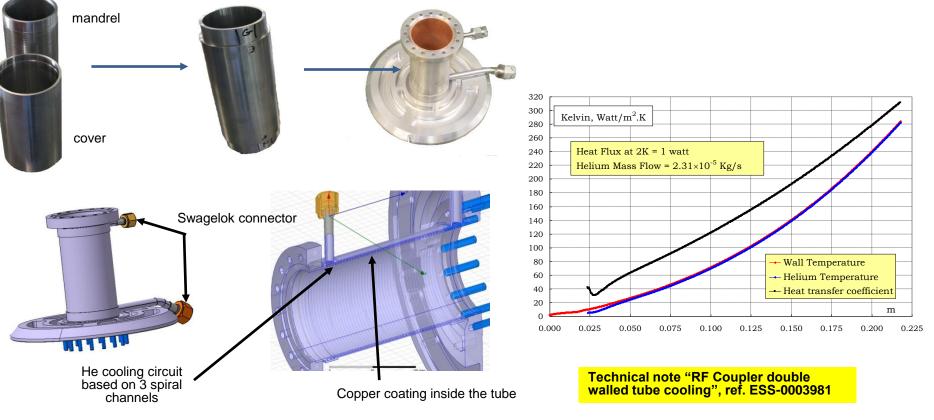
coupler



## **DOUBLE-WALL TUBE**

**ess** 

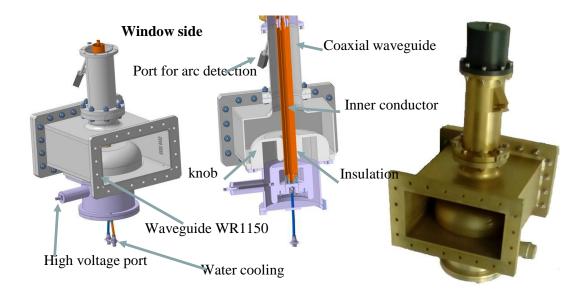
- Stainless steel 316L
- Cooling circuit manufactured with the shrink-fitting method
- Copper coating with 10µm(-3/+2µm) thickness and RRR∈ [20;40] (threshold between RF and thermal aspects)







- Insulation obtained with a material with a dielectric constant =3.3 (+/-10%) able to provide 10kV insulation (breakdown voltage ≥18kV). Use of PEEK
- Insulation cylinder obtained from solid material and machining.
- Protective coating for aluminum parts: alodine 1200
- Water tightness

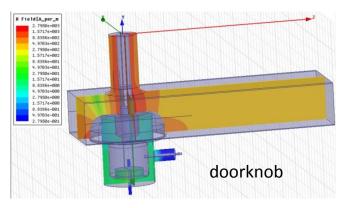




#### **COOLING CIRCUITS**



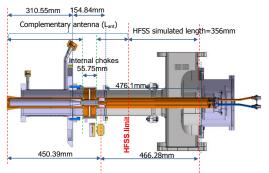
 Estimation of the power dissipated by the coupler (simulation and analytical calculation)



For 1.1 MW peak, duty cycle 5% -RF power dissipation of the antenna: in travelling wave 58W in standing wave 94W -RF power dissipation of the ceramic (tan  $\delta$ =3×10<sup>-4</sup>) in travelling wave 9.3W in standing wave 40W (worst case)

Magnetic field distribution

Cooling of the antenna



Technical note "Definition of the water characteristics for the cooling system of the elliptical cavity coupler" (ref. CEA-ESS-CMD-NT-0003 A)

Φ	Δτ			
2 l/min	0.97°			
2.5 l/min	0.78°			
3 l/min	0.65°			

Estimation of the water flow

During the conditioning: for  $\Phi$ =2.4l/min

T water input=25.6°C

T water output=26.2°C

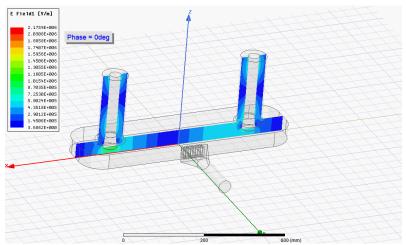
couplers

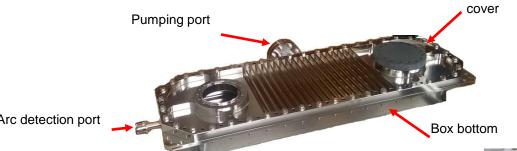


### **CONDITIONING BOX**



- Pumping port and port for arc detection
- Aluminum wire used as seal between cover and bottom for vacuum tightness
- Dimensions of the box defined to have the box common to medium and high beta couplers





Arc detection port

Technical note "Test box for the power couplers of the elliptical cavities – Mechanical, thermal and RF study" (ref. ESS-0015806)



Aluminum wire

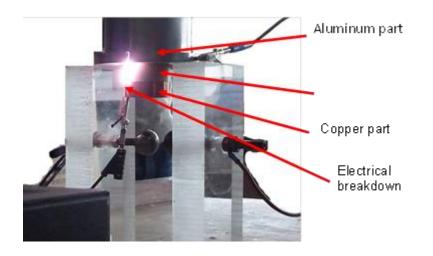




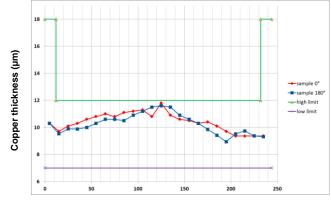
- Window, tube, electron pick-up: check of vacuum tightness
- Window and doorknob: check of the water tightness
- Doorknob: check of the insulation







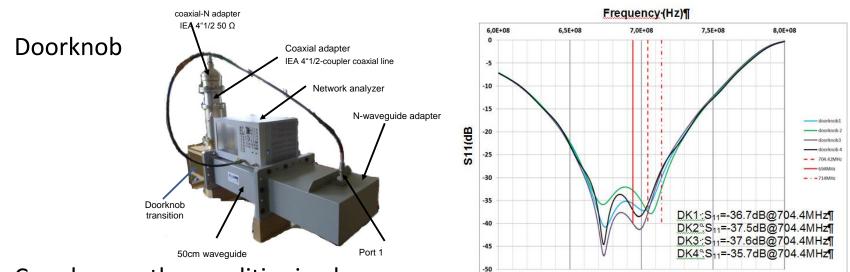
#### Check of the copper coating thickness



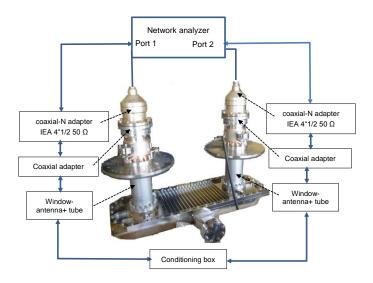


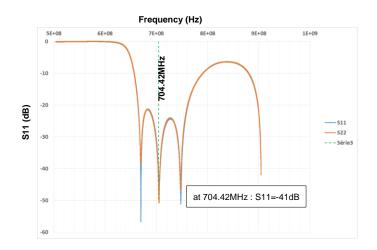
#### **RF CHARACTERIZATION**





Couplers on the conditioning box







- Double-wall tubes cleaned in an ultrasonic bath with Tickopur R33
- Cleaning of the window-antenna with cleanroom wiper, use of alcohol and RBS T310
- Assembly in a ISO 4 cleanroom Double-wall tube





# Cleaning of the antenna with alcohol and RBS T310 if oxidation marks





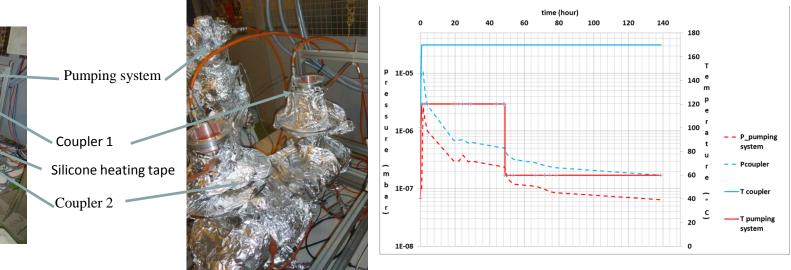
Procedure "Procédure de montage des coupleurs en salle blanche" in progress

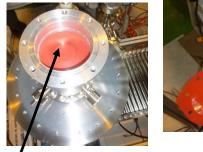




- Baking of the couplers mounted on a test box: 170°C for 110H,
- Baking of the pumping system at 120°C for 48H then 60°C for 62H









Silicone seal to cover the air part

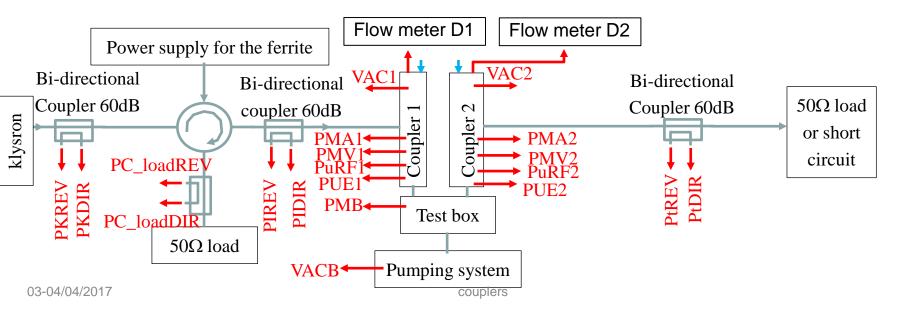


Air part of the window antenna is under nitrogen to avoid oxidation of the copper parts





- 5 Photomultipliers (HAMAMATSU H10721-110):
  - Coupler1: 1PM vacuum side (PMV1) , 1PM air side (PMA1)
  - Coupler 2: 1PM vacuum side (PMV2) , 1PM air side (PMA2)
  - Box: 1PM (PMB)
- 2 electron pick-up / RF (coupler 1+coupler 2)
  - Coupling 80dB (10.4dBm for 1.1MW in TW, 16.4dBm in SW with Emax in front of pick-up antenna)
- 3 vacuum gauges:IKR070 with TPG300 controller from Pfeiffer (Coupler 1 (VAC1) & 2 (VAC2) + pumping system (VACB))
- 5 temperature probes (PT100): 2 for water cooling,1 for each coupler (set up on the window close to the ceramic), 1 for the test box
- 8 RF signals: Reverse and forward powers for each bidirectional coupler
- Security signals: 3 vacuum signals from the controllers, 2 water signals from flow meters (relays)



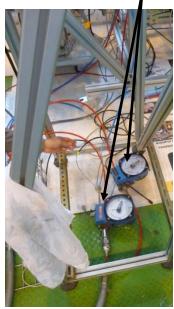


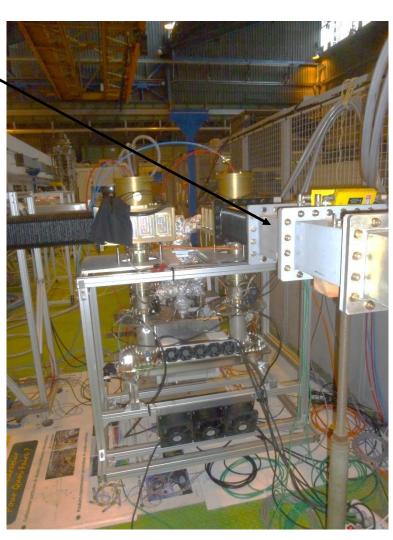


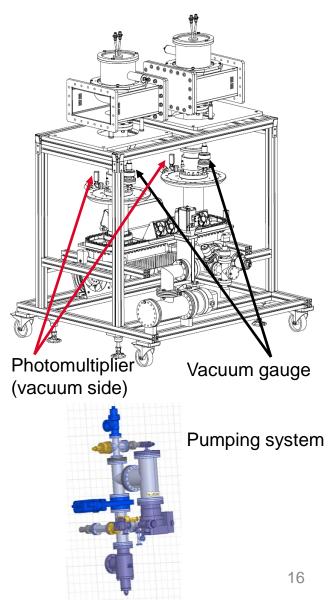
Position of each diagnosis components

Bidirectional coupler (input Power :incident & reflected power)

Flow meter (ouptut water) & Temperature probes (water)





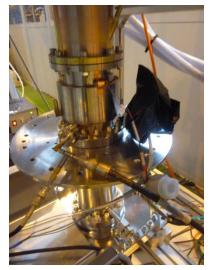


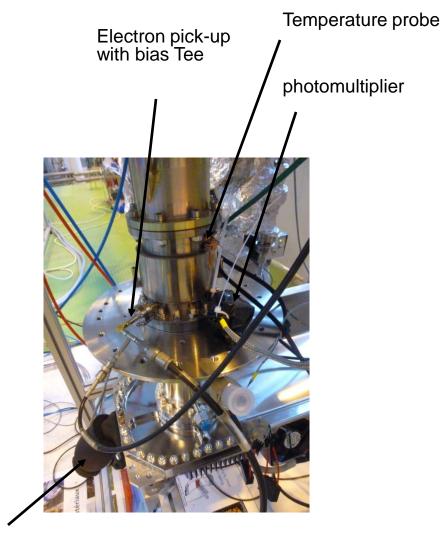


## **OVERVIEW OF THE CONDITIONING BENCH (2/2)**







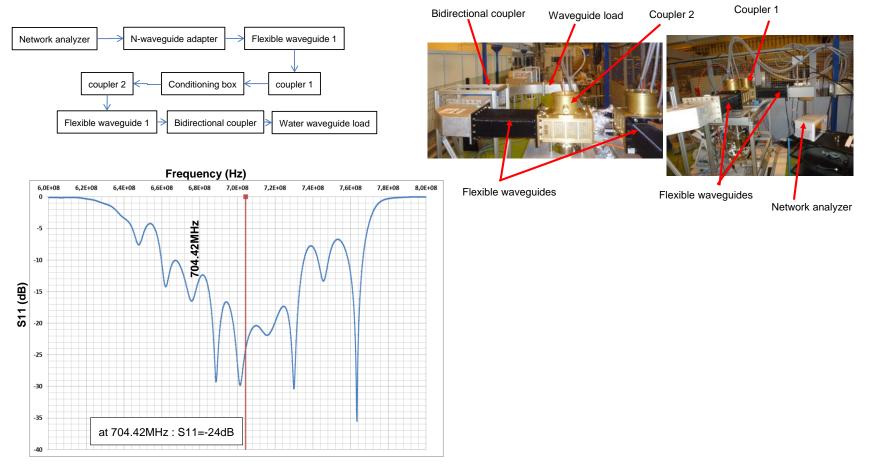


Box photomultiplier





 Measurement of the reflection coefficient of the pair of couplers with all the waveguide components (load 50Ω)





#### **CONDITIONING SEQUENCE**



## • Sequence for travelling wave

Step	Pulse	Repetition	Duty cycle	Power[kW]
	width			
		[Hz]		
TW-L01	0.03	1	0.003%	15 - 1200
TW-L02	0.1	1	0.01%	15 - 1200
TW-L03	0.2	1	0.02%	15 - 1200
TW-L04	0.4	1	0.04%	15 - 1200
TW-L05	0.8	1	0.08%	15 - 1200
TW-L06	1.2	1	0.12%	15 - 1200
TW-L07	1.6	1	0.16%	15 - 1200
TW-L08	2	1	0.2%	15 - 1200
TW-L09	2.5	1	0.25%	15 - 1200
TW-L10	3	1	0.3%	15 - 1200
TW-L11	3.6	1	0.36%	15 - 1200
TW-H01	0.2	14	0.28%	15 - 1200
TW-H02	0.4	14	0.56%	15 - 1200
TW-H03	0.8	14	1.12%	15 - 1200
TW-H04	1.2	14	1.68%	15 - 1200
TW-H05	1.6	14	2.24%	15 - 1200
TW-H06	2	14	2.8%	15 - 1200
TW-H07	2.5	14	3.5%	15 - 1200
TW-H08	3.0	14	4.2%	15 - 1200
TW-H09	3.6	14	5.04%	15 - 1200
TW-H10	3.6	14	5.04%	1200 for 1h

## •Sequence for standing wave (2 positions of the short circuit)

Step	Pulse	Repetition	Duty cycle	Power[kW]
	width			
	[ms]	[Hz]		
SW-S01	0.05	1	0.005%	15 - 1200
SW-S02	0.1	1	0.01%	15 - 1200
SW-S03	0.2	1	0.02%	15 - 1200
SW-S04	0.3	1	0.03%	15 - 1200
SW-S05	0.4	1	0.04%	15 - 1200
SW-S06	0.5	1	0.05%	15 - 1200
SW-S07	0.5	2	0.1%	15 - 1200
SW-S08	0.5	4	0.2%	15 - 1200
SW-S09	0.5	8	0.4%	15 - 1200
SW-S10	0.5	14	0.7%	15 - 1200
SW-L01	0.8	14	1.12%	15 - 300
SW-L02	1.5	14	2.1%	15 - 300
SW-L03	2.5	14	3.5%	15 - 300
SW-L04	3	14	4.2%	15 - 300
SW-L05	3.6	14	5.04%	15 - 300

#### •S10 & L05: P ≤2×10<sup>-8</sup>mbar

#### •From L01 to H10: RF Time ≤120 hours •H09 & H10: P ≤2×10<sup>-8</sup>mbar

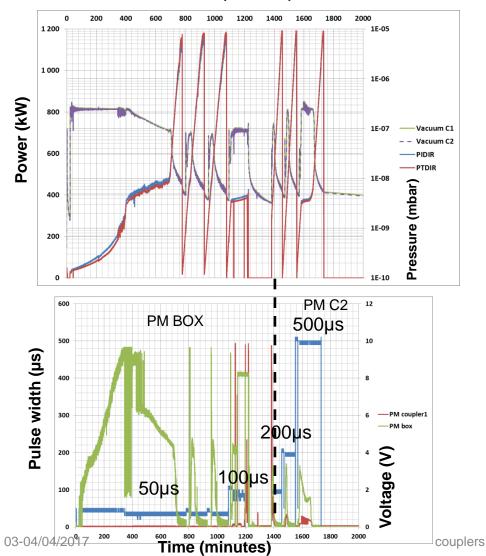
### **CONDITIONING-TRAVELLING WAVE (1/2)**

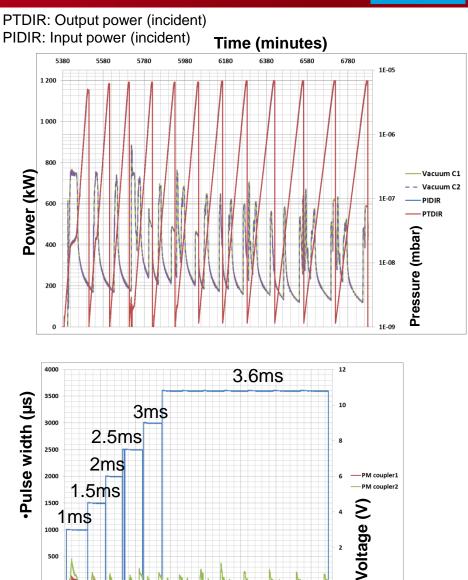
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Time (minutes)

• Results for repetition period=1.2second

Time (minutes)

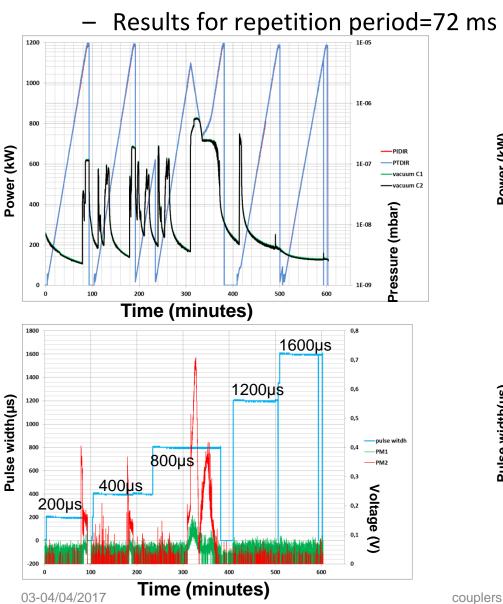


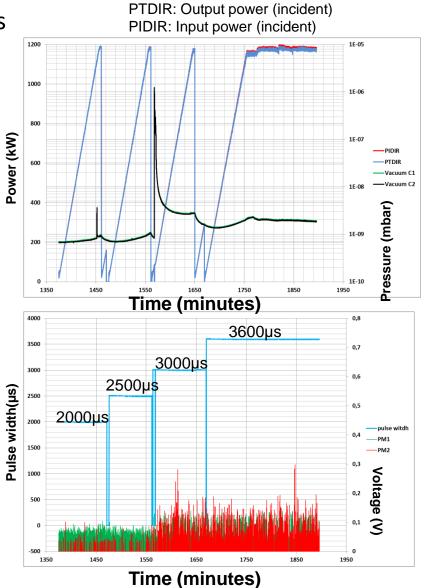




## **CONDITIONING-TRAVELLING WAVE (2/2)**



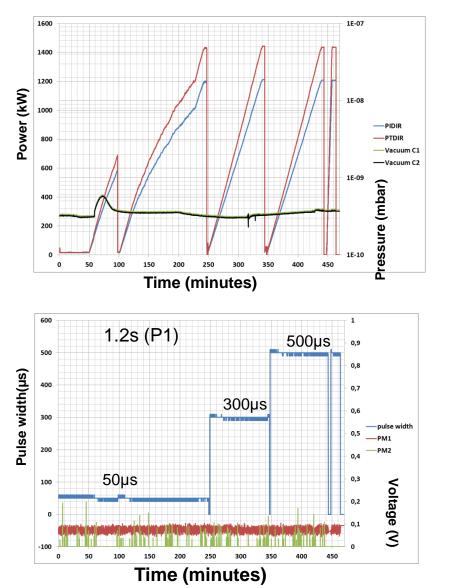


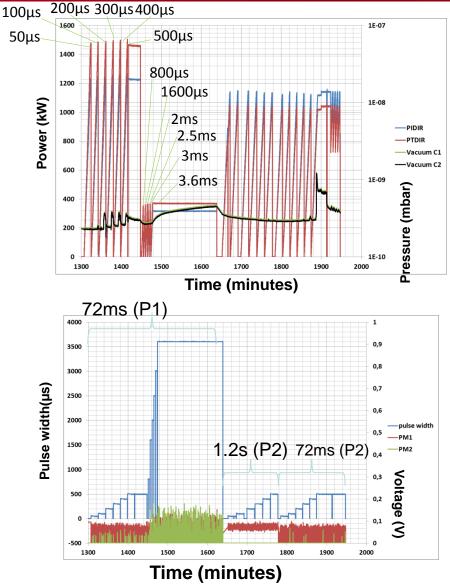




#### **CONDITIONING-STANDING WAVE**

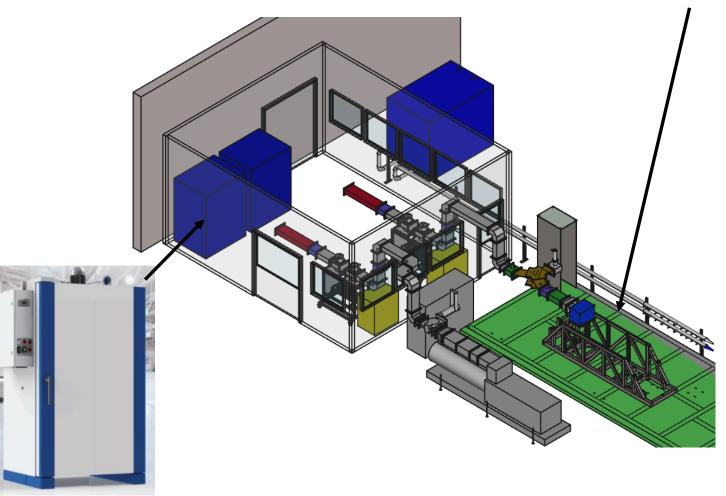








- New baking system (furnace)
- Use of two 704 MHz klystrons in parallel (new klystron ordered)



03-04/04/2017





- Overview of the manufacturing for prototypes:
  - 6 medium beta double-wall tubes
  - 10 windows
  - 8 doorknob transitions
  - In progress, manufacturing of 6 high beta double-wall tubes (delivery in June 2017)
- Conditioning of 2 pairs of couplers with success (these couplers are assembled in cavities)





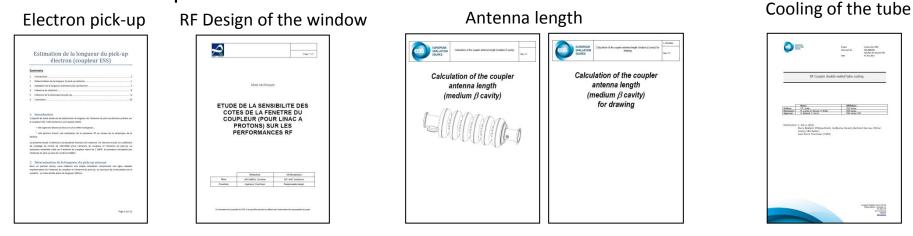
- Conditioning of the third pair of couplers in progress
- Conditioning of the first pair of high beta couplers foreseen in June 2017



#### **TECHNICAL NOTES**



• List of the technical notes written in the framework of the coupler development



#### Water for cooling

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			Autorio Dele and el	

#### Test box characterization

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			CEARME.7
		Overs	18.3m 205
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#### Procedure of coupler assembly in cleanroom

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	Nome	Fonction	Institut	Date et eignatures
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Redigé par :	C. ARCANDAL	Reportable IIV coulleur	CEA	
Vertile par :	C. SERVOUN		CEA	
Vertfe per :	C. BERRY		CEA	
vertte par :	G. DEVANZ	Assponable scientifique	CEA	
vertte par :	C. CLOUE	Ingeneure Quality	CEA	
Approuve per :	F. PEAUGER	Responsable IVP CEA	CEA	
		lorisă par : Piorence Ardell 6 et ografure :	er, Chef de p	ngel 500

# Thank you

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